Docket No.: 1592-0164PUS1

App No.: NEW Docket No.: Inventor: Eiichi SHIMIZU et al.
Title: VAPOR PHASE GROWTH APPARATUS

NEW SHEET

Sheet 1 of 3

1/3 FIG.1

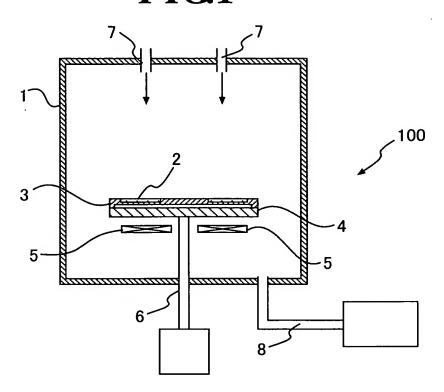
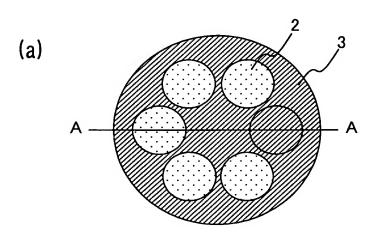
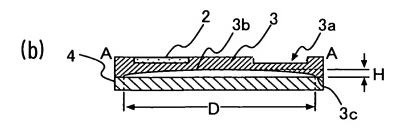


FIG.2





App No.: NEW Inventor: Eiichi SHIMIZU et al.

Title: VAPOR PHASE GROWTH APPARATUS

NEW SHEET

Sheet 2 of 3

2/3 FIG.3

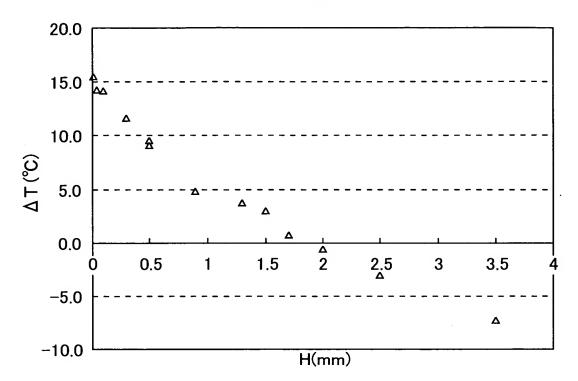
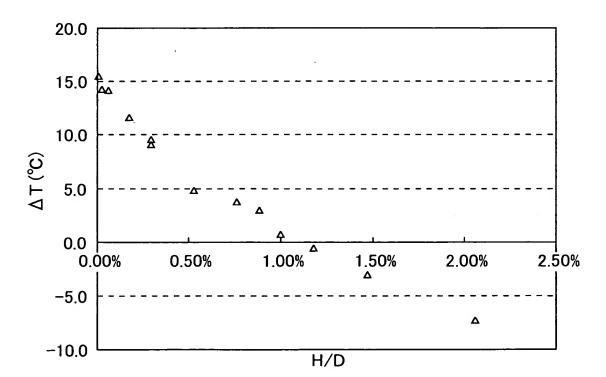


FIG.4



Docket No.: 1592-0164PUS1

App No.: NEW Docket No.: Inventor: Eiichi SHIMIZU et al. Title: VAPOR PHASE GROWTH APPARATUS NEW SHEET

Sheet 3 of 3

3/3 FIG.5

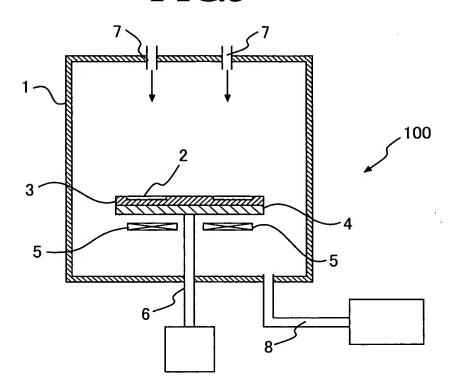


FIG.6

